

IDS of 3/19/04

FORM PTO/SB/08A/B (10-01) Substitute for PTO-1449A/B	Attorney Docket Number	52180/CM/M277
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)	Application Number	Not yet assigned
	Filing Date	March 18, 2004
	Applicant(s)	Stewart Middlemiss
	Group Art Unit	Not yet assigned
	Examiner Name	Not yet assigned

U.S. PATENT DOCUMENTS				
EXAMINER INITIALS	Cite No. ¹	DOCUMENT NUMBER Number - Kind Code ² (If Known)	Publication Date MM-DD-YYYY	Name of Patentee
<i>hm</i>		3,141,855	07-21-1964	R.H. Wentorf, Jr.
<i>hm</i>		4,268,276	05-19-1981	Bovenkerk
<i>hm</i>		4,907,377	03-13-1990	Csillag, et al.

FOREIGN PATENT DOCUMENTS					
EXAMINER INITIALS	Cite No. ¹	FOREIGN PATENT DOCUMENT Country Code ³ - Number ⁴ - Kind Code ⁵ (If Known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T ⁶ (✓)
<i>hm</i>		EP 0 392 467 A	10-17-1990	Sumitomo Electric Industries, Ltd.	

OTHER DOCUMENTS		
EXAMINER INITIALS	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
<i>hm</i>		DATABASE COMPENDEX Online; "Advancing the art of PCD tool grinding"; Manufacturing Engineering; XP002269771; Abstract; Vol. 104, No. 2, 2-1990; pp. 41-42; Engineering Information, Inc.; New York, NY
<i>hm</i>		FIELD, J.E., "Properties of Diamonds," 1979; selected pages (pp. 20-21, 90-91, 100-101, 642-643, and 652-653); Academic Press
<i>hm</i>		WENTORF, R.H., Jr., et al.; "Preparation of Semiconducting Diamonds," <i>The Journal of Chemical Physics</i> ; Volume 36, No. 8; April 13, 1962; pp. 1987-1990
<i>hm</i>		WENTORF, R.H., Jr.; "Diamond Formation at High Pressures," <i>Advances in High Pressure Research</i> ; 1974; (selected pages) (pp. 249-281); Academic Press

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EXAMINER SIGNATURE	<i>[Signature]</i>	DATE CONSIDERED	3/30/05
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.pto.gov or MPEP 901.4. ³Enter Office that issued the document, by the two-letter code (WIPO standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English Language Translation is attached.

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